## CLAIMS

- A polishing solution for metal comprising
   an additive which permits chemical mechanical
   polishing to be carried out without solid abrasive grains,
- (2) an oxidizing agent and (3) water.
- 2. A polishing solution for metal comprising
  (1) an oxidizing agent, (2) an oxidized-metal dissolving
  agent, (3) a metal etching rate inhibitor, and (4) water.

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